



IFW

00684.003654

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takako YAMAGUCHI et al.) : Examiner: Unassigned
Application No.: 10/529,891) : Group Art Unit: 1756
Completion of Entry into U.S. National) :
Stage Under 35 U.S.C. § 371(c): July 26, 2005) : Confirmation No.: 7802
For: EXPOSURE MASK, METHOD OF DESIGNING AND : July 21, 2006
MANUFACTURING THE SAME, EXPOSURE)
METHOD AND APPARATUS, PATTERN FORMING :
METHOD, AND DEVICE MANUFACTURING)
METHOD :
METHOD :

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:


Further to the Information Disclosure Statements filed June 29, 2005, and May 16, 2006, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

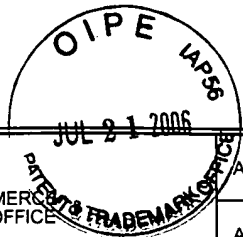
Respectfully submitted,



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SEW/eab



FORM PTO 1449 (modified)		ATTY DOCKET NO. 00684.003654		APPLICATION NO. 10/529,891			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		APPLICANT Takako YAMAGUCHI et al.					
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		FILING DATE July 26, 2005			GROUP 1756		
July 21, 2006							
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US-6,559,926 B2	05/06/2003	Yamaguchi et al.	355	53	
		US-6,628,392 B2	09/30/2003	Kuroda et al.	356	400	
		US-6,632,593 B2	10/14/2003	Yamaguchi et al.	430	322	
		US-6,720,115 B2	04/13/2004	Inao et al.	430	5	
		US-7,001,696 B2	02/21/2006	Inao et al.	430	5	
		2006/0014108 A1	01/19/2006	Ito et al.	430	322	
		2006/0007440 A1	01/12/2006	Kuroda et al.	356	400	
		2006/0003269 A1	01/05/2006	Ito et al.	430	323	
		2006/0003236 A1	01/05/2006	Mizutani et al.	430	5	
		2005/0064301 A1	03/24/2005	Yamaguchi et al.	430	5	
		2005/0057752 A1	03/17/2005	Inao et al.	356	400	
		2004/0166421 A1	08/26/2004	Yamaguchi et al.	430	5	
		2004/0121245 A1	06/24/2004	Inao et al.	430	5	
		2004/0023161 A1	02/05/2004	Yamaguchi et al.	430	311	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.